

DOCKET NO: 285995US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
KOHEI KAWAMURA, ET AL. : EXAMINER: PARENDO, KEVIN A.
SERIAL NO: 10/567,733 :
FILED: FEBRUARY 10, 2006 : GROUP ART UNIT: 2823
FOR: METHOD FOR FORMING FILM, :
METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE,
SEMICONDUCTOR DEVICE AND
SUBSTRATE TREATMENT SYSTEM

RESPONSE TO RESTRICTION REQUIREMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

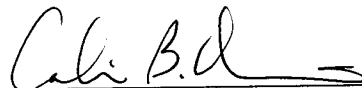
SIR:

In response to the Office Action dated January 5, 2009, Applicants elect, without traverse, Group I corresponding to Claims 1-9, 10-12, and 14-15. Applicants make this election based on the understanding that Applicants are not prejudiced against filing one or more divisional applications that cover the non-elected claims.

Accordingly, Applicants respectfully request an early and favorable action on Claims 1-9, 10-12, and 14-15.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



Steven P. Weihrouch
Attorney of Record
Registration No. 32,829

Customer Number
22850

Tel: (703) 413-3000
Fax: (703) 413 -2220
(OSMMN 08/07)

Colin B. Harris
Registration No. 58,969